



IFJ

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Chih-Ming Ke

Serial No.: 10/628,914

Filed: 07/29/2003

For: CD SEM Automatic Focus  
Methodology And Apparatus For  
Constant Electron Beam Dosage  
Control

Group Art Unit: 2881

Examiner: Huynh, Andy

Confirmation No. 8121

TKHR Docket No.: 252016-2160  
Top-Team Ref. 0503-A30751US

Certificate of Mailing

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail, postage prepaid, in an envelope addressed to: Mail Stop PGPUB; Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450, on March 4, 2005.

  
Signature - Hui Chin Barnhill

**REQUEST FOR CORRECTED PUBLICATION**

**UNDER 37 CFR 1.221(b)**

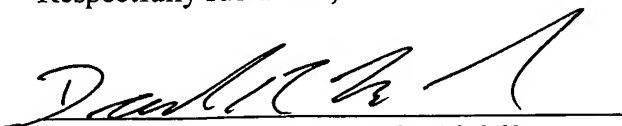
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Sir:

The Applicants respectfully bring to the attention of the USPTO the publication of the incorrect patent application at Publication No. 2005/0023463 A1. The specification and claims published is not that which was filed with the USPTO on July 29, 2003. Attached hereto is a true copy of the specification and claims as filed, as well as a copy of the application that was erroneously published.

No fee is believed to be due in connection with this Request. However, if any fee is believed to be due, you are hereby authorized to debit our account 20-0778.

Respectfully submitted,

By:   
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